Number of Supplier participated: 1

Awarded	Supplier	Event - Lot Title	<b>Bid Quantity</b>	Price (SGD)	Total Bid (SGD)	Awarded Quantity (SGD)	Awarded Spend (SGD)
Yes							
	Oxford Instruments Plasma						
		Supply, Install and					
		Commissioning of 2 units					
		of Inductive Coupled					
		Plasma Etching System					
		to Temasek Laboratories,					
		NTU	2	746,358.45	1492716.9	2.00	1492716.9